P/10-658



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

fent Application of

Richard BLACK

Serial No.: 10/759,690

Filed: January 16, 2004

New York, New York

Date: July 12, 2005

Group Art Unit: 2838

Examiner:

For: DV/DT-DETECTING OVERCURRENT PROTECTION CIRCUIT FOR POWER

SUPPLY

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on July 12, 2005

Louis C. Dujmich

Name of applicant, assignee or Registered Representative

> Signature July 12, 2005

Date of Signature

Respectfully submitted.

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LCD:ih Enclosures

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(Use several streets if necessary)								
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PART	U.S. PATEN	T DOCUME	NTS (not submitted for applica	ations filed aft	er 6/30/03)			
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